

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Ichiro MITSUYOSHI

Serial No.: 10/813,323

Filed: March 29, 2004

For: SUBSTRATE PROCESSING APPARATUS

Confirmation No. 5119

Date: March 27, 2008

Group Art Unit: 3652

Examiner: Jennifer HERRERA

VIA EFS WEB

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in an Office Action issued by the Japanese Patent Office on January 29, 2008 in connection with a counterpart foreign application and that this communication, to the best of applicant's knowledge, was not received by any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of this Submission.

I respectfully request that the information submitted be considered and the required \$180.00 fee is also transmitted electronically herewith.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

THIS CORRESPONDENCE IS BEING
SUBMITTED ELECTRONICALLY
THROUGH THE UNITED STATES
PATENT AND TRADEMARK OFFICE
EFS FILING SYSTEM
ON MARCH 27, 2008



MAX MOSKOWITZ

Registration No.: 30,576

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700